

U.S. Department of Commerce, Patent and Trademark Office

Docket No.:

7390/AKT/DISPLAY/RKK

Serial No.:

10/601,185

LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicant(s):

Shinichi Kurita et al.

Filing Date:

06/20/03

Group:

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Mr</i>	AA	4,455,177	06/19/84	Filippov et al.			
<i>Mr</i>	AB	4,632,624	12/30/86	Mirkovich et al.			
<i>Mr</i>	AC	4,790,750	12/13/98	Bourel et al.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
<i>Mr</i>	AL	EP 0 928 014 A2	07/07/99	EPO				
<i>Mr</i>	AM	EP 1 065 701 A2	01/03/01	EPO				
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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Date Considered

11/29/04

*EXAMINER: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

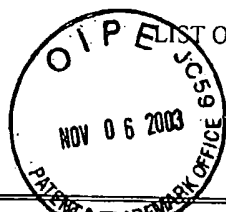
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<i>jm</i>	AA	5,085,887	02/04/92	Adams et al.			
	AB	5,421,957	06/06/95	Carlson et al.			
	AC	6,019,839	02/01/00	Achutharaman et al.			
	AD	6,093,252	07/25/00	Wengert et al.			
	AE	6,099,697	08/08/00	Hausmann			
	AF	6,286,451 B1	09/11/01	Ishikawa et al.			
	AG	6,326,597 B1	12/04/01	Lubomirsky et al.			
	AH	6,383,330 B1	05/07/02	Raaijmakers			
<i>jm</i>	AI	6,390,019 B1	05/21/02	Grimbergen et al.			
	AJ						
	AK						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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Examiner

Anthony M. Gendall

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11/29/04

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